



S.N. 10/670,356  
Page 1

Dkt. 520.39728VX1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: M. HATANO, et al.  
Application No.: 10/670,356  
Filed: September 26, 2003  
For: THIN FILM SEMICONDUCTOR DEVICE,  
POLYCRYSTALLINE SEMICONDUCTOR THIN FILM  
PRODUCTION PROCESS AND PRODUCTION APPARATUS  
Art Unit: 2813  
Examiner: T. NGUYEN

**AMENDMENT**

**MS: AMENDMENTS**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

May 5, 2006

Sir:

In response to the Office Action dated December 5, 2005, the period of response for which extension of time is requested in the attached Petition for Extension of Time, please amend the above-identified application as listed below and as set forth on the following pages:

**Amendments to the Claims; and**

**Remarks are included following the Amendments.**